

Notice of References Cited		Application/Control No. 10/589,802	Applicant(s)/Patent Under Reexamination KOBAYASHI ET AL.	
		Examiner Vivian Chen	Art Unit 1794	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-7,026,064	04-2006	Tsunekawa et al.	428/847.4
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